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Docket No.: H6810.0021/P021
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Akira Sekine et al.

Application No.: 09/858,477

Art Unit: 1743

Filed: May 17, 2001

Examiner: Yelena G. Gakh

For: METHOD AND SYSTEM FOR
COMPREHENSIVE MANAGEMENT OF
CHEMICAL MATERIALS

AMENDMENT AFTER FINAL REJECTION

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

INTRODUCTORY COMMENTS

In response to the Office Action dated August 25, 2004, please amend the above-identified U.S. patent application as follows:

Amendments to the Claims begin on page 2 of this paper.

Remarks/Arguments begin on page 7 of this paper.